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Investigation of the thickness mode in surface stabilized ferroelectric liquid crystal cells

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Dielectric properties of surface stabilized ferroelectric liquid crystal (SSFLC) cells have been investigated both experimentally and theoretically. The thickness mode is found to consist of two relaxation processes. A decomposition of an analytical solution of the complex dielectric permittivity $\varepsilon(\omega)$ in terms of these processes is given. The experimental results show agreement with theory and lead to the conclusion that the thickness mode can be separated into two processes. It has been found that the ratio of the dielectric strengths for the two processes depends on the cell thickness, and that the ratio of their frequencies is approximately equal to 10. The lower frequency process is assigned to the relaxation within the bulk and the higher frequency process is assigned to the fluctuations of molecules at the two surfaces of the cell. The latter process is seen only in thicker cells for the reason that anchoring at surfaces predominantly controls the behaviour of thinner cells.

Dielectric spectroscopy is a powerful technique for is applied along the *X* -axis. investigating the relaxation mechanism and thereby The spatial and temporal torque balances are described the modes of operation of ferroelectric liquid crystal by the dynamic equation (FLC) cells $[1-3]$. For frequencies below 1 MHz, two collective relaxation processes are known to exist: one is a fluctuation in the tilt angle (θ) —soft mode; the second is a fluctuation in the azimuthal angle (φ) —Goldstone mode. The dielectric properties of FLC cells are found Equation (1) is solved for φ subject to the boundary to be dependent on the cell thickness $[4]$. In sufficiently conditions detailed in $[4]$. The complex permittivity is thick FLC cells the dielectric properties are governed found in terms of the surface anchoring parameters, the by the helical structure; the dielectric strength and the elastic constant and the cell thickness. The equations relaxation time of the Goldstone mode depend on the for the director profiles, in terms of the variation of the helical pitch $[5]$. A theory for the dielectric response of azimuthal angle, as a function of X for both the helical pitch [5]. A theory for the dielectric response of a helical cell in the SmC* and the SmA phase has been shelf and chevron cell geometries of the cell have been developed by Carlsson *et al.* [5] and Zeks *et al.* [6]. In determined. The relaxation mode resulting from these a surface stabilized ferroelectric liquid crystal (SSFLC) calculations is called the *X* -mode or the thickness mode, cell the helix is unwound by the surface interactions, and to distinguish it from the helical dynamic process. The the dielectric parameters of the Goldstone mode depend dielectric measurements in certain cases have shown the on the cell thickness. We recently developed a theoretical existence of two relaxation processes in a SSFLC cell. model [4] to explain the thickness dependence of the Under certain conditions the 'thickness' mode was shown dielectric behaviour for SSFLC cells. This model is based not to follow the Debye behaviour. on the dynamic distribution of the azimuthal angle φ of In this paper, we wish to investigate the dependence of

1. Introduction for a chevron cell. The external electric field, $E_0 \cos \omega t$,

$$
\gamma_{\varphi} \sin^2 \theta \frac{\partial \varphi}{\partial t} = K_{\varphi} \sin^2 \theta \frac{\partial^2 \varphi}{\partial x^2} + \mathbf{P}_s E_0 \cos \omega t \sin \varphi. \quad (1)
$$

the director with respect to the *X* -axis, shown in figure 1, the relaxation mode/modes on the sample thickness. We analyse the analytical solution of the dynamic equation *Author for correspondence for the thickness mode in two relaxation processes, Debye

Figure 1. The smectic layer structure for the chevron geometry in FLC cells. $N =$ molecular director, $L =$ smectic layer normal, **R** = rubbing direction, **C** = *C* director, θ = molecular tilt angle, φ = azimuthal angle, δ = smectic layer tilt. On the right, director profiles: $UL =$ uniform left, $UU =$ uniform up, $UR =$ uniform right, $UD =$ uniform down, $TL =$ twisted left.

strengths. The nature of these processes is investigated cesses given by the Debye term and for $\alpha = 1$, the Cole for cells, possessing the chevron structure, as these Davidson term. Results of numerical fitting are shown possess higher thermodynamic stability compared with in figures 2 and 3. Figure 2 shows the normalized their bookshelf counterparts. $\ddot{\theta}$ dielectric strength whereas figure 3 shows the relaxation

2. Theory

The normalized complex dielectric permittivity of a chevron SSFLC cell, based on the model outlined in the introduction and detailed in our previous paper [4], is found to be:

$$
\varepsilon(\omega) = \frac{2(1+2\Lambda)}{(-i\omega\tau_c)^{1/2}}\n\times \frac{\left[1-\cos(-i\omega\tau_c)^{1/2}\right]}{\left[\sin(-i\omega\tau_c)^{1/2}+2\Lambda(-i\omega\tau_c)^{1/2}\cos(-i\omega\tau_c)^{1/2}\right]}
$$
\n(2)

where

$$
\tau_{\rm c} = \gamma d^2 / (4K). \tag{3}
$$

of the cell, *K* is the elastic constant, γ is the rotational viscosity, *w* is the surface anchoring energy and τ_c is a relaxation time for *X* mode/modes for a chevron cell. In the derivation of equation (2), the electronic and atomic polarizations were neglected and the complex dielectric permittivity was also normalized, with $\varepsilon_s = 1$, $\varepsilon_{\infty} = 0$.

Since equation (2) shows a complicated dependence of complex permittivity on frequency, we therefore analyse equation (2) by first fitting the dielectric data generated by this equation to known relaxation functions for different values of Λ using a WinFit (Novocontrol) program. The best results of fitting are obtained if the data generated by equation (2) are fitted to the following function [10]:

$$
\varepsilon(\omega) = \frac{\Delta \varepsilon_1}{1 + i\omega \tau_1} + \frac{\Delta \varepsilon_2}{\left[1 + \left(i\omega \tau_2\right)^{\alpha}\right]^{\beta}}
$$
(4)

and Cole–Davidson [7], and examine their relative with $\alpha \cong 1$. Equation (4) is the sum of relaxation protimes for the two processes obtained using this fitting

 $\Lambda = K/dw$ is a dimensionless parameter, *d* is the thickness Figure 2. Plot of normalized dielectric strengths as a function of the cell K is the electric constant μ is the rotational of the parameter Λ .

procedure. It should be noted that the parameter β found from the data fitting depends on Λ .

Figure 2 shows that when the parameter Λ is large enough (i.e., much greater than 0.01), there exists pre dominantly only a single relaxation process in the thick ness mode of a SSFLC cell, since $\Delta \varepsilon_2$ tends to zero as $\Lambda \gg 0.01$. This single relaxation process appears to follow the Debye equation. However for small values of Λ , two relaxation processes are found in the thickness mode of the SSFLC cells. Hence the existence of the second process depends on the parameter Λ , and indirectly on the thickness of the cell, since the latter is the only variable parameter in the simulation.

To analyse the spectrum of the complex dielectric permittivity $e(\omega) = e'(\omega) - ie''(\omega)$ generated by equation (2), Figure 4. Plot of parameter *g* versus parameter ξ for two different values of Λ . we introduce the parameters η and ξ defined as in [8]:

$$
\xi = \frac{\tau_0 \omega \left[\varepsilon'(\omega) - \varepsilon_{\infty} \right]}{\varepsilon''(\omega)} \tag{5}
$$

$$
\eta = \frac{\varepsilon_{\rm s} - \varepsilon''(\omega)}{\tau_0 \omega \varepsilon''(\omega)}\tag{6}
$$

where $\varepsilon_s = \lim_{\omega \to 0} \varepsilon(\omega)$, $\varepsilon_{\infty} = \lim_{\omega \to \infty} \varepsilon(\omega)$, $\tau_0 = a$ time constant which is of the order of the relaxation time of the system under investigations. $\xi = \tau_0 / \tau$, $\eta = \tau / \tau_0$ when the spectrum $\varepsilon(\omega)$ consists of only a single Debye process:

$$
\varepsilon(\omega) = \varepsilon_{\infty} + \frac{\Delta \varepsilon}{1 + i\omega \tau}.
$$
 (7)

It was shown by Barriol *et al.* [8] that if the spectrum $e(\omega)$ is a sum of two Debye processes, namely: Figure 5. Theoretical dielectric loss spectra for FELIX 18/100

$$
\varepsilon(\omega) = \varepsilon_{\infty} + \frac{\Delta \varepsilon_1}{1 + i\omega \tau_1} + \frac{\Delta \varepsilon_2}{1 + i\omega \tau_2} \tag{8}
$$

$$
\eta = \frac{\tau_1 + \tau_2}{\tau_0} - \frac{\tau_1 \tau_2}{\tau_0^2} \xi. \tag{9}
$$

versus ξ is no longer a straight line, but is a curve with may consist of more than two Debye-type processes frequency as a variable. For a single Debye relaxation, or two relaxations times with a distribution around we get a single point on the *q* versus ξ plot; a curve may one or both of these processes. However, by analysing lead to the system having either more than two processes curves in figures 4 and 5 in the low frequency region, or one or both of these processes may have a distribution we note that the main relaxation process is Debye-type of relaxation times. and the second process in this frequency range can

loss $\varepsilon''(\omega)$ versus $\omega \tau_c / (2\pi)$ on a log-log plot. Plots in Also, in the high frequency region the slope of the curve figures 4 and 5 were calculated using equation (2) with in figure 5 is less than predicted for a single Debye the parameter Λ equal to (i) 0.001 and (ii) 0.1. process.

for values of parameter $\Lambda = 0.1$ and $\Lambda = 0.001$.

then the plot of variable *q* versus ξ is a straight line with From the plot in figure 4 and for $\Lambda = 0.001$ and $\Lambda = 0.1$, ω as the running variable:
 ω as the running variable: lines and these curves are also far removed from a single point. On applying the physical concepts of Selfran [9], we find that the thickness mode consists of two processes which cannot be approximated by a sum of two In all other cases, Salefran [9] found that the plot of η single Debye processes. As mentioned above, the system For the analysis of a chevron cell, we use the aforesaid also be approximated by the Debye equation in the low transformation equations (5) and (6). Figure 4 shows frequency range. For ζ \leq 200, η versus ζ is a straight the dependence of η on ξ and figure 5 shows dielectric line whereas for higher values of ξ the slope changes.

This type of behaviour at higher frequencies can processes: best be described by a Cole-Davidson [7] type process $\frac{\tau_1 + \beta \tau_2}{\tau_1 + \beta \tau_2}$

$$
\varepsilon(\omega) = \varepsilon_{\infty} + \frac{\Delta \varepsilon}{\left(1 + i\omega \tau\right)^{\beta}}
$$
 (10)

where $0 < \beta < 1$. In the low frequency region, Cole-Davidson behaviour approximates to a Debye process with a slope equal to unity, whereas for high frequencies,
the quations (13) and (14), the relaxation time τ_1 of
the slope is less than unity and is equal to β . Based on the slope is less than unity and is equal to *b*. Based on the main Debye process and the value of $\beta \tau_2$ for the this analysis we can infer that the dielectric response of a second high frequency process in the thickne SSFLC cell is the sum of the Debye and Cole-Davidson processes: processes: $\frac{\tau_1}{\tau_2}$

$$
\varepsilon(\omega) = \varepsilon_{\infty} + \frac{\Delta \varepsilon_1}{1 + i\omega \tau_1} + \frac{\Delta \varepsilon_2}{\left(1 + i\omega \tau_2\right)^{\beta}} \tag{11}
$$

where $\varepsilon_s = \Delta \varepsilon_1 + \Delta \varepsilon_2 = 1$, $\varepsilon_{\infty} = 0$.

is that for $\Lambda = 0.1$, the second process has very low (16), the dielectric strengths of both proces dielectric strength relative to the first, and the relaxation evaluated using (12) and the results become: dielectric strength relative to the first, and the relaxation time in comparison to the main Debye process is different from that for $A = 0.001$. Since the second process has relatively low dielectric strength for $\Lambda = 0.1$, it may not in any case be easy to find this process. This leads to where $Q = (1 + 10A)/12(1+A)$. the conclusion that the presence of the second process in the thickness mode of a SSFLC cell depends on the

parameters for both processes based on the model because of its relatively large helical pitch of about parameters for both processes experimentally The 25 km, such that the fabrication of surface stabilized and then to find these processes experimentally. The $\frac{25 \mu m}{\mu}$, such that the fabrication of surface stabilized activation of the dislective strength and the relevation estimation of the dielectric strength and the relaxation time of both processes is based on the transformations cells with 6, 15 and 30 μ m spacings at room temper-
given by equations (5) and (6). The parameter β can be found from the analysis of the slope of the dielectric peak in the high frequency region of figure 5 for an described by the Havriliak and Negami equation [10]:
appropriate value of *A*. For $\omega \tau \gg 1$, we can expand equation (11) and on taking the first two terms in the series expansion, the dielectric response of a SSFLC (9) where $\epsilon = 4\pi$ in the relation for the relations for the parameters of both We showed in the relations for the relations for the relations for t

$$
\varepsilon \cong \frac{\Delta \varepsilon_1}{1 + i\omega \tau_1} + \frac{\Delta \varepsilon_2}{1 + i\omega \beta \tau_2}.
$$
 (12)

below. By substituting $e(\omega)$ from equation (2) into frequency process is Debye type and the second high equations (5) and (6) and comparing the Taylor series frequency process is of Cole–Davidson type, as predicted expansions for η and ξ in the low frequency range, by the theory. But for the cell with a thickness of 6 μ m, we obtain the dependence $\eta = A - B\xi$. Then by using only one (Debye type) process appears in the spectra

by a Cole–Davidson [7] type process
\nm:
\n
$$
\frac{\tau_1 + \beta \tau_2}{\tau_c} = A = \frac{29 + 250A - 1428A^2 - 12584A^3}{30(1 + 2A)(9 + 12A - 460A^2)}
$$
\n
$$
\varepsilon(\omega) = \varepsilon_{\infty} + \frac{\Delta \varepsilon}{(1 + i\omega \tau)^{\beta}}
$$
\n(10)
\nIn the low frequency region, Cole–
\nOur approximates to a Debye process
\n(14)

second high frequency process in the thickness mode of a chevron cell are found to be as follows:

$$
\frac{\tau_1}{\tau_c} = \frac{A}{2} + \left(\frac{A^2}{4} - B\right)^{1/2} \tag{15}
$$

$$
\frac{\beta \tau_2}{\tau_c} = \frac{A}{2} - \left(\frac{A^2}{4} - B\right)^{1/2}.
$$
 (16)

Another conclusion that can be obtained from figure 2 Using values of τ_1 and $\beta \tau_2$ from equations (15) and that for $\Lambda = 0.1$, the second process has very low (16), the dielectric strengths of both processes can be

$$
\Delta \varepsilon_{\rm l} = \frac{(Q - \tau_2/\tau_{\rm c})\tau_{\rm c}}{\tau_1 - \tau_2} \qquad \Delta \varepsilon_{\rm l} = \frac{(\tau_1/\tau_{\rm c} - Q)\tau_{\rm c}}{\tau_1 - \tau_2}.\tag{17}
$$

3. Results and discussion

The FLC mixture used was FELIX 18/100 purchased
The objective of this paper is to estimate the dielectric
parameters for both processes based on the model
the objective of the objective parameters for both processes based The measurements are made on homogeneously aligned ature. Dielectric spectra were fitted by using WINFIT (Novocontrol) program up to $n = 3$ processes as

$$
\varepsilon(\omega) = \frac{G}{\omega^{1-S}C_0} + \sum_{j=1}^{n} \frac{\Delta \varepsilon_j}{[1 + (i\omega \tau_j)^{\alpha_j}]^{\beta_j}}
$$
(18)

becomes:
where *G* is the d.c. conductivity, *S* is a fitting parameter usually close to zero and *C*⁰ is a geometrical capacitance. Figures 6, 7 and 8 show measured dielectric loss spectra and their fit to the spectra for the chevron cells under investigation. From these figures we find that for cells The parameters $\Delta \epsilon_1$, $\Delta \epsilon_2$, τ_1 , $\beta \tau_2$ of equation (11) are with thicknesses of 30 and 15 μ m, the thickness mode estimated using equations (5), (6) and (9), as shown (or *X*-mode) consists of two processes (or X -mode) consists of two processes: the main low frequency process is of Cole–Davidson type, as predicted only one (Debye type) process appears in the spectra.

 $18/100$ (Hoechst) for a cell of thickness $15 \,\mu \text{m}$.

Figure 8. Experimental dielectric loss spectra for FELIX Figure 9. The static distribution of the azimuthal angle $\varphi(x)$, 18/100 (Hoechst) for a cell of thickness 6 μ m. computed from the analytical solution of equatio

ness, provided this is the only variable in the experiment.
A change in the cell thickness influences both constituent and $7 \mu m$. A change in the cell thickness influences both constituent

components of the X -mode. These are being confirmed by the experimental results. Decreasing the cell thickness *d*, and consequently increasing *A*, the high frequency process is suppressed. It has indeed been found that for a $6 \mu m$ cell, the high frequency process is absent. For a 30 μ m cell, we find $\varepsilon_1 / \varepsilon_2 = 5$ and $\tau_1 / \tau_2 = 6$ and for a 15 μ m cell $\varepsilon_1 / \varepsilon_2 = 28$ and $\tau_1 / \tau_2 = 8$. These results are in qualitative agreement with theory.

Figures 5, 6 and 7 show the presence of a relatively very low frequency peak centred at \sim 30 Hz. This presumably is due to a domain process which is commonly observed [11, 12] at very low frequencies in FLC cells.

Next, the problem of assignment of the relaxation processes is considered. Equation (2) is based on the Figure 6. Experimental dielectric loss spectra for FELIX calculation of the dynamic variation of the azimuthal 18/100 (Hoechst) for a cell of thickness 30μ m. function of *X* . Figure 9 shows such a plot of the static variations of the director profile. The dynamic profiles correspond to the fluctuations of the static profile with time. For thicker cells, the profile can fluctuate both at the surfaces as well as in the bulk simply for the reason that the azimuthal angle is found to be greatly dependent on *X* in comparison with that for a thin cell. However for thinner cells, the director profile seemingly can only fluctuate within the bulk since in this case the azimuthal angle does not appear to depend much on *X* . Here the surface anchoring significantly influences the fluctuations within the bulk too; such a significant control of the surface anchoring is lost as the cell thickness is gradually increased. Hence process 1 given by the relaxation time Figure 7. Experimental dielectric loss spectra for FELIX τ_1 , common to both thick and thin cells, belongs to the

about its equilibrium position $\varphi = \varphi_0$ for a cell possessing parameters of the *X*-mode are found to be very strongly
dependent on the parameter $A = K/dw$ or the cell thick-
dependent on the parameter $A = K/dw$ or the cell thick-
 $w = 10^{-4}$ J m⁻², $\varphi_0 = 60^{\circ}$. On the figure, curv

fluctuations within the bulk, whereas τ_2 seen only, in experiments indirectly support our calculations for the the thicker cells, belongs to fluctuations at the surfaces. director profiles in FLC cells, given in figure 9, which From another point of view, director fluctuations at the are also supported by measurements of Fuzi and Sambles surfaces and the bulk are unresolvable in a thin cell, $\left[13\right]$ using guided modes technique. unlike the situation in a relatively thick cell.

Qualitative agreement between predictions from our model and experimental results show that cells with
large sample thicknesses exhibit more than a single [1] GOUDA, F., SKARR, K., and LAGERWALL, S. T., 1991, large sample thicknesses exhibit more than a single $\begin{bmatrix} 1 \end{bmatrix}$ GOUDA, F., SKARP, K. Televation time. The results show two relevation modes *Ferroelectrics*, 113, 165. relaxation time. The results show two relaxation modes
for the parameter $\Lambda(A = K/dw) < 0.01$, whereas almost a
single relaxation mode is found for $\Lambda \gg 0.01$. The results
single relaxation mode is found for $\Lambda \gg 0.01$. The single relaxation mode is found for $\Lambda \gg 0.01$. The results [3] KREMER, F., SCHÖNFELD, A., VALLERIEN, S. U., also show that the observed single relaxation mode is of KAPITZA, A., ZENTEL, R., and FISCHER, E. W., 1990, the *Phys. Rev. A,* 42, 3667.
 Complicated The Complex permittivity and [4] PANARIN, YU. P., KALMYKOV, YU. P., MACLUGHADHA, frequency dependence of the complex permittivity and $^{[4]}$ PANARIN, YU. P., KALMYKOV, YU. P., MACLUGHADHA, $^{[4]}$ S. T., X_U, H., and V_{IJ}, J. K., 1994, *Phys. Rev. E*, 50, 4763. this behaviour has been resolved in terms of the two
modes. In a thick cell, the low frequency mode is of [5] CARLSSON, T., ŽEKŠ, B., FILIPIČ, C., and LEVSTIK, A.,
1990, Phys. Rev. A, 42, 877. Debye type, whereas the high frequency mode is of Cole-
Davidson type The higher frequency mode annears to URBANC, B., 1993, Liq. Cryst., 15, 103. Davidson type. The higher frequency mode appears to URBANC, B., 1993, *Liq. Cryst.*, 15, 103.
The surfaces of the Fig. 12. The DAVIDSON, D. W., and COLE, R. H., 1950, J. Chem. arise from the director fluctuations at the surfaces of the
cell; a variation in the microscopic properties of surfaces
gives rise to a macroscopic fluctuation or a distribution
in the relaxation times, and consequently to in the relaxation times, and consequently to a Cole [9] SALEFRAN, J. L., 1977, *Chem. Phys. Lett.*, **45**, 124.
Davidson type mechanism On the contrary the low [10] HAVRILIAK, S. JR., and NEGAMI, S., 1967, *Polymer*, **8**, 1 Davidson type mechanism. On the contrary, the low [10] HAVRILIAK, S. JR., and NEGAMI, S., 1967, *Polymer*, **8**, 161. type mechanism. On the contrary, the low [11] PANARIN, YU. P., XU, H., MACLUGHADHA, S. T., and frequency mode seen even in a thin cell is assigned to
the fluctuations in the bulk similar to that in a thick cell.
The higher frequency mode relates to the fluctuations of
the director at the surfaces. The results of th

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- the director at the surfaces. The results of the dielectric [13] Fuzi, Y., and Sambles, J. R., 1993, *L iq. Cryst*., **13,** 1.